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01.10.2020

Department of Physics

Corrigendum-1

Tender Reference no: PHY/2020/021/MSRA/PARMS

Name of the Item: Plasma Assisted RF, DC Magnetron Sputtering (PARMS) unit

Corrigendum details: Changes in technical specifications

Sl. No.	Previous Technical Specifications	Revised Technical Specifications
5.	<u>Magnetron sources:</u> <ul style="list-style-type: none"> • All magnetrons should be UHV compatible. 	<u>Magnetron sources:</u> <ul style="list-style-type: none"> • All magnetrons should be flexi-head. UHV compatible magnetrons may be offered as optional items.
8.	<u>Vacuum pumping system:</u> <ul style="list-style-type: none"> • Reputed make dry scroll pump having displacement capacity of minimum 15 m³/h. 	<u>Vacuum pumping system:</u> <ul style="list-style-type: none"> • Reputed make dry scroll pump having displacement capacity of minimum 10 m³/h.

All other terms and conditions remain the same.

Tender Inviting Authority:

The Senior Manager,
 Project Purchase,
 IC&SR Building, IIT Madras
 Chennai 600036